



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Mohab Chandra et al.

Title: DEVICE AND METHOD FOR MULTICRYSTALLINE SILICON WAFERS

Docket No.: 884.B40US1

Serial No.: 10/692,611

Filed: October 24, 2003

Due Date: August 2, 2006

Examiner: G. Nagesh Rao

Group Art Unit: 1722

MS Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

☒ Return postcard.

☒ Amendment and Response (9 pgs.).

☒ Petition for Extension of Time (1 pg.)

☒ Permission to charge Deposit Account No. 19-0743 in the amount of \$450.00 to cover the Extension of Time Fee.

Please consider this a **PETITION FOR EXTENSION OF TIME** for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

By: 

Atty: David C. Peterson

Reg. No. 47,857

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 2nd day of August, 2006.

Amy Moriarty

Name

Signature

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)